

PATENT Customer No. 22,852 Attorney Docket No. 08038.0032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE ONTED STATES PATERT AND TRADEMARK OFFICE	
In re Application of:	
Takayuki NIUYA et al.	Group Art Unit: 2812
Serial No.: 09/658,193	Examiner: Not yet assigned
Filed: September 8, 2000	
For: METHOD OF MANUFACTURING () SEMICONDUCTOR DEVICE AND () MANUFACTURING APPARATUS ()	RECEIVE
Assistant Commissioner for Patents Washington, DC 20231	E. 100M
Sir:	3
PRELIMINARY AMENDMENT	
Prior to the examination of the above application, please amend this application	
as follows:	

IN THE SPECIFICATION:

Page 1, before line 5, insert:

 A_1

--cross-reference to related application

This application is a Continuation of International Application No.

PCT/JP00/03544, filed June 1, 2000.--

LAW OFFICES
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Beginning on page 2 and continuing thru page 4, delete the entire section entitled Disclosure of Invention and replace it with the following: